



Attorney Docket No.:  
SP02-260

ITW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: BELLMAN, et al.

Serial No: 10/722,769

Filing Date: November 26, 2003

Title: METHOD USING MULTI-  
COMPONENT COLLOIDAL  
ABRASIVES FOR CMP  
PROCESSING OF  
SEMICONDUCTOR AND  
OPTICAL MATERIALS

Group Art Unit: 1765

Examiner: CHEN, Kin Chan

**RESPONSE**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**RESPONSE TO THE EXAMINER'S RESTRICTION REQUIREMENT**

In response to the Office Action dated March 3, 2005 in the above-captioned application, please enter the following Amendments and Remarks.

Amendment to the specification begins at page 2 in this paper.

Amendments to the claims begin at page 3 in this paper.

Remarks begin on page 7 in this paper.